

Notice of References Cited	Application/Control No. 10/564,742	Applicant(s)/Patent Under Reexamination ENDO ET AL.	
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U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-			
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FOREIGN PATENT DOCUMENTS

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	N	CN 1416189	05-2003	China	Chen et al.	
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NON-PATENT DOCUMENTS

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